Notice of References Cited Application/Control No. 10/613,419 Examiner Lawrence B. Williams Applicant(s)/Patent Under Reexamination FENG ET AL. Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2005/0018702 A1	01-2005	Chen et al.	370/431
*	В	US-2003/0231581 A1	12-2003	Son, Jung-Min	370/208
*	C	US-2002/0150036 A1	10-2002	Weerackody, Vijitha	370/208
*	D	US-2002/0176509 A1	11-2002	Gatherer et al.	375/260
*	Е	US-6,445,747 B1	09-2002	Jafarkhani et al.	375/285
*	F	US-6,961,369 B1	11-2005	Tzannes, Marcos C.	375/220
*	G	US-2003/0142754 A1	07-2003	Jung et al.	375/260
*	Ι	US-7,126,980 B1	10-2006	Breiling, Marco	375/146
	_	US-			
	٦	US-			
	K	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Z					
	0					
	Р					
	Q					
	R					
	S					
	Τ					

NON-PATENT DOCUMENTS

*	* Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)							
	U							
	V							
	W							
	x							

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.